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April **7**, 2004

Mail Stop Missing Parts Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Applicant(s):

Wayne Glenn Renken, Earl Jensen, and Roy Gordon

Title:

Integrated Process Condition Sensing Wafer and Data Analysis System

Application No.:

10/718,269

Filing Date:

November 19, 2003

Examiner:

Unknown

Group Art Unit:

Unknown

Docket No.:

**SENS.008US3** 

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9982

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 9, 2004

Signature

# SUBMISSION OF REPLACEMENT DRAWINGS

## Dear Sir:

Replacement drawings consisting of Figures 1-10D in the above-named application are hereby submitted. If there are any questions regarding these drawings, please call the undersigned attorney at (415) 318-1167.

Respectfully submitted,

Peter A. Gallagher Reg. No. 47,584 4/9/04 Date

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